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Application Number				09/412,512	
Filing Date				October 5, 1999	
First Named Inventor				Shunpei YAMAZAKI	
Group Art Unit				2812	
Examiner Name				R. Booth	
Attorney Docket Number				0756-2046	
Sheet	1	of	1		

U.S. PATENT DOCUMENTS						
Examiner Initials <sup>5</sup>	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			

FOREIGN PATENT DOCUMENTS								
Examiner Initials <sup>5</sup>	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>2</sup> (if known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
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RA		U.S. Patent Application Serial No. 09/352,194, including Specification, Drawings, Pending Claims and Pending Office Action, "Crystalline Semiconductor Thin Film, Method of Fabricating the Same Semiconductor Device, and Method of Fabricating the Same", Shunpei Yamazaki et al., July 13, 1999.	
RA		U.S. Patent Application Serial No. 09/894,125, including Specification, Drawings Pending Claims and Pending Office Action, "Crystalline Semiconductor Thin Film, Method of Fabricating the Same Semiconductor Device, and Method of Fabricating the Same", Shunpei Yamazaki et al., June 29, 2001.	

Examiner Signature		Date Considered	9/16/02
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